

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Peter KOCHERSPERGER

Appl. No.: 10/780,877

Filed: February 19, 2004

For: **Overlay Correction By Reducing
Wafer Slipping After Alignment**

Confirmation No.: 1990

Art Unit: 2822

Examiner: Duong, Khanh B.

Atty. Docket: 1857.2140000

Comments on Statement of Reasons for Allowance

Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Mail Stop: Issue Fee

Sir:

Applicant thanks the Examiner for indicating the allowability of claims 12 and 24-38 in the Notice of Allowance dated June 24, 2010.

Comments on Statement of Reasons for Allowance

Applicant notes the Examiner's Statement of Reasons for Allowance presented on pages 3-4 of the Notice of Allowance. Applicant reserves the right to demonstrate claims 12 and 24-38 are allowable over the art made of record for further reasons related to any of their recited features. Applicant further contends that reservation of this right does not give rise to any implication regarding whether the Applicant agrees with or acquiesces in the reasoning provided by the Examiner.

Respectfully submitted,

STERN, KESSLER, GOLDSTEIN & FOX P.L.L.C.

Jason D. Eisenberg
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Date: 7/29/10

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